



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 9561

SERIAL NUMBER 10/549,698	FILING OR 371(c) DATE 07/14/2006 RULE	CLASS 118	GROUP ART UNIT 1709	ATTORNEY DOCKET NO. 2342-0142PUS1
APPLICANTS Masanori Sakai, Takaoka-shi, JAPAN; Toru Kagaya, Toyama-ken, JAPAN; Hirohisa Yamazaki, Toyama-shi, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP04/09820 07/09/2004 <i>ke</i>				
** FOREIGN APPLICATIONS ***** JAPAN 2003-293953 08/15/2003 <i>ke</i>				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/04/2006				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>[Signature]</i> <i>KE</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 10
INDEPENDENT CLAIMS 3				
ADDRESS 2292				
TITLE Substrate treatment apparatus and method of manufacturing semiconductor device				
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	